

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

JIN-XING LI ETA L.

Serial No.: 10/528,765

Filed: December 1, 2006

For: TWO LAYER LTO TEMPERATURE
OXIDE BACKSIDE SEAL FOR A WAFER

Group Art Unit: 1794

Examiner: Jonathan C. Langman

Attorney Docket No.: WSAG 0107 PUSA

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Amendment
Commissioner for Patents
U.S. Patent & Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is a response to the Restriction Requirement of November 9, 2009. Applicant elects without traverse to prosecute Group II, comprising Claims 64-67, drawn to an article.

Prompt and favorable consideration of this application is requested. If the Examiner notes any minor errors, the Examiner is invited to telephone the undersigned so that the matter can be promptly handled by Examiner's amendment.

Respectfully submitted,

JIN-XING LI ETA L.

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Date: December 2, 2009

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